

JPW



Attorney Docket 0553-0393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Shunpei Yamazaki et al.)
Serial No.: 10/757,167)
Filed: January 13, 2004)
For: Method For Manufacturing Conductive)
Layer And Semiconductor Device)
Art Unit: 2822)
Examiner: Christy L. Novacek)

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Shannon Wallace

Signature

7/15/05

Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Sir:

In response to the Office Action of April 18, 2005, please amend the above-identified
application as follows:

~~07/19/2005 SFELEKE1 00000023 10757167~~

~~02 FC:1201 1000.00 0P~~

07/20/2005 SFELEKE1 00000010 10757167
01 FC:1201 200.00 0P
02 FC:1202 800.00 0P